

The documentation and process conversion measures necessary to comply with this revision shall be completed by 24 January 2015.

INCH-POUND

MIL-PRF-19500/539G
 24 October 2014
 SUPERSEDING
 MIL-PRF-19500/539F
 30 December 2012

PERFORMANCE SPECIFICATION SHEET

* TRANSISTOR, NPN, SILICON, POWER DARLINGTON, TYPES 2N6300 AND 2N6301, JAN, JANTX, AND JANTXV

This specification is approved for use by all Departments and Agencies of the Department of Defense.

The requirements for acquiring the product described herein shall consist of this specification sheet and [MIL-PRF-19500](#).

1. SCOPE

* 1.1 Scope. This specification covers the performance requirements for NPN silicon, power Darlington transistors. Three levels of product assurance are provided for each encapsulated device type (JAN, JANTX, and JANTXV) as specified in [MIL-PRF-19500](#).

* 1.2 Package outlines. The device package outline is as follows: TO-213AA (formerly TO-66) in accordance with [figure 1](#) for all encapsulated device types.

1.2 Physical dimensions. The device package style is TO-213AA (formerly TO-66) in accordance with [figure 1](#).

1.3 Maximum ratings. Unless otherwise specified, $T_c = +25^\circ\text{C}$.

Types	P_T (1)			$R_{\theta JC}$ (2)	V_{CBO}	V_{CEO}	V_{EBO}	I_c	I_B	T_J and T_{STG}
	$T_c = 0^\circ\text{C}$	$T_c = 27^\circ\text{C}$	$T_c = 100^\circ\text{C}$							
	<u>W</u>	<u>W</u>	<u>W</u>	<u>$^\circ\text{C}/\text{W}$</u>	<u>V dc</u>	<u>V dc</u>	<u>V dc</u>	<u>A dc</u>	<u>mA dc</u>	<u>$^\circ\text{C}$</u>
2N6300	75	65	37	2.66	60	60	5	8	120	-55 to +200
2N6301	75	65	37	2.66	80	80	5	8	120	-55 to +200

(1) See [figure 2](#) for temperature-power derating curves.

(2) See [figure 3](#) for thermal impedance curve.

Comments, suggestions, or questions on this document should be addressed DLA Land and Maritime ATTN: VAC, P.O. Box 3990, Columbus, OH 43218-3990, or emailed to semiconductor@dla.mil. Since contact information can change, you may want to verify the currency of this address information using the ASSIST Online database at <https://assist.dla.mil>.

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1.4 Primary electrical characteristics. Unless otherwise specified, $T_C = +25^\circ\text{C}$.

Limit	h_{FE2} (1) $V_{CE} = 3 \text{ V dc}$ $I_C = 4 \text{ A dc}$	h_{FE3} (1) $V_{CE} = 3 \text{ V dc}$ $I_C = 8 \text{ A dc}$	$ h_{fe} $ $V_{CE} = 3 \text{ V dc}$ $I_C = 3 \text{ A dc}$ $f = 1 \text{ MHz}$	C_{obo} $100 \text{ kHz} \leq f \leq 1 \text{ MHz}$ $V_{CB} = 10 \text{ V dc}$ $I_E = 0$	Pulse response	
					t_{on}	t_{off}
Min	750	100	25	μF	μs	μs
Max	18,000		350	200	2.0	8.0

Limit	$V_{BE(sat)2}$ (1) $I_C = 8 \text{ A dc}$ $I_B = 80 \text{ mA dc}$	$V_{CE(sat)2}$ (1) $I_C = 8 \text{ A dc}$ $I_B = 80 \text{ mA dc}$	h_{fe} $V_{CE} = 3 \text{ V dc}$ $I_C = 3 \text{ A dc}$ $f = 1 \text{ kHz}$
Min	V dc	V dc	300
Max	4.0	3.0	

(1) Pulsed see 4.5.1.

- * 1.5 Part or Identifying Number (PIN). The PIN is in accordance with MIL-PRF-19500, and as specified herein. See 6.4 for PIN construction example and 6.5 for a list of available PINs.
- * 1.5.1 JAN certification mark and quality level. The quality level designators for encapsulated devices that are applicable for this specification sheet from the lowest to the highest level are as follows: "JAN", "JANTX", and "JANTXV".
- * 1.5.2 Device type. The designation system for the device types of transistors covered by this specification sheet are as follows.
 - * 1.5.2.1 First number and first letter symbols. The transistors of this specification sheet use the first number and letter symbols "2N".
 - * 1.5.2.2 Second number symbols. The second number symbols for the transistors covered by this specification sheet are as follows: "6300" and "6301".
- * 1.5.3 Lead finish. The lead finishes applicable to this specification sheet are listed on QML-19500.

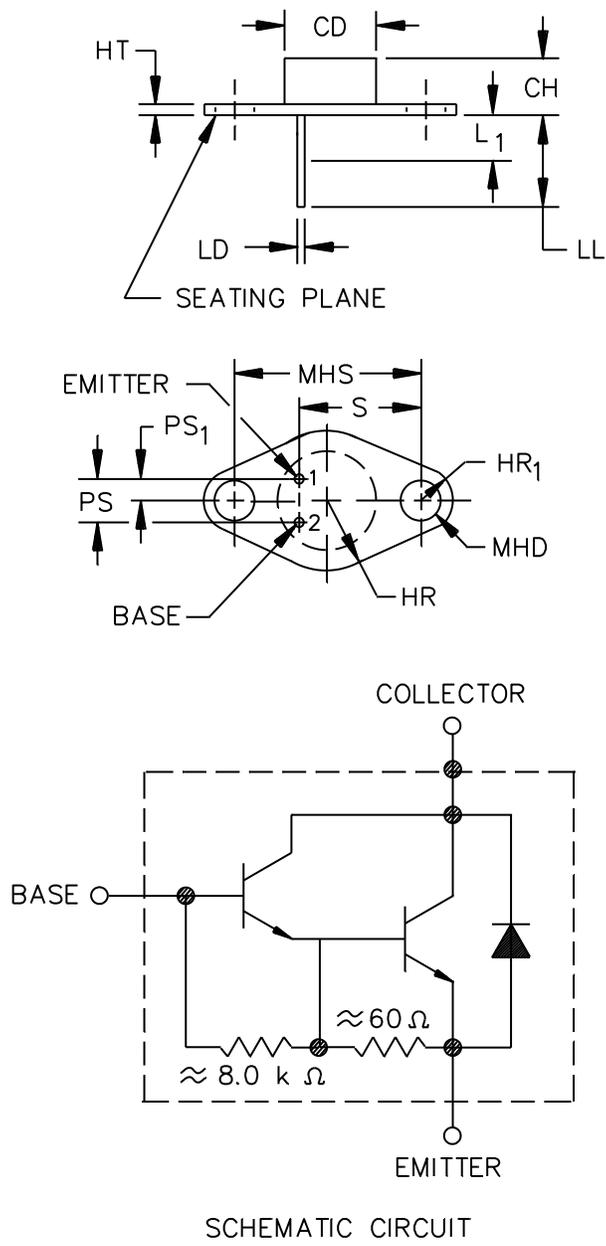


FIGURE 1. Physical dimensions and schematic (TO-213AA, formerly TO-66).

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Ltr	Dimensions				Notes
	Inches		Millimeters		
	Min	Max	Min	Max	
CD	.470	.500	11.94	12.70	3
CH	.250	.340	6.35	8.64	
HR		.350		8.89	
HR ₁	.115	.145	2.92	3.68	4
HT	.050	.075	1.27	1.91	3, 5
LD	.028	.034	0.71	0.86	6, 7
LL	.360	.500	9.14	12.70	6
L ₁		.050		1.27	6, 8
MHD	.142	.152	3.61	3.86	4
MHS	.958	.962	24.33	24.43	
PS	.190	.210	4.83	5.33	9
PS ₁	.093	.107	2.37	2.71	9
S	.570	.590	14.48	14.99	9

NOTES:

1. Dimensions are in inches. Millimeters are given for general information only.
2. Terminal 1 is the emitter and terminal 2 is the base. The collector shall be electrically connected to the case.
3. Body contour is optional within zone defined by dimension CD.
4. Applies to two holes, at both ends.
5. Dimension HT does not include sealing flanges.
6. Applies to both terminals.
7. The lead diameter (dimension LD) is uncontrolled within dimension L₁. Dimension LD applies beyond dimension L₁ to the end of dimension LL.
8. Within this zone the lead diameter may vary to allow for lead finishes and irregularities.
9. These dimensions shall be measured at points .050 inch (1.27 mm) to .055 inch (1.40 mm) below seating plane. When gauge is not used, measurement shall be made at seating plane.
10. The seating plane of header shall be flat within .001 inch (0.03 mm), concave to .004 inch (0.10 mm), convex inside a .520 inch (13.20 mm) diameter circle on the center of the header, and flat within .001 inch (0.03 mm), concave to .006 inch (0.15 mm), convex overall.
11. In accordance with ASME Y14.5M, diameters are equivalent to Φ x symbology.

FIGURE 1. Physical dimensions and schematic (TO-213AA, formerly TO-66) - Continued.

2. APPLICABLE DOCUMENTS

- * 2.1 General. The documents listed in this section are specified in sections 3 and 4 of this specification. This section does not include documents cited in other sections of this specification or recommended for additional information or as examples. While every effort has been made to ensure the completeness of this list, document users are cautioned that they must meet all specified requirements of documents cited in sections 3 and 4 of this specification, whether or not they are listed.

2.2 Government documents.

2.2.1 Specifications, standards, and handbooks. The following specifications, standards, and handbooks form a part of this document to the extent specified herein. Unless otherwise specified, the issues of these documents are those cited in the solicitation or contract.

[MIL-PRF-19500](#) - Semiconductor Devices, General Specification for.

DEPARTMENT OF DEFENSE STANDARDS

[MIL-STD-750](#) - Test Methods for Semiconductor Devices.

- * (Copies of these documents are available online at <http://quicksearch.dla.mil/>).

2.3 Order of precedence. Unless otherwise noted herein or in the contract, in the event of a conflict between the text of this document and the references cited herein, the text of this document takes precedence. Nothing in this document, however, supersedes applicable laws and regulations unless a specific exemption has been obtained.

3. REQUIREMENTS

3.1 General. The individual item requirements shall be as specified in [MIL-PRF-19500](#) and as modified herein.

3.2 Qualification. Devices furnished under this specification shall be products that are manufactured by a manufacturer authorized by the qualifying activity for listing on the applicable qualified manufacturers list before contract award (see 4.2 and [6.3](#)).

3.3 Abbreviations, symbols, and definitions. Abbreviations, symbols, and definitions used herein shall be as specified in [MIL-PRF-19500](#) and as follows:

I_M	-	The measurement current applied to forward bias the junction for measurement of V_{BE} .
I_H	-	The collector current applied to the device under test during the heating period.
t_H	-	The duration of the applied heating power pulse.
t_{sw}	-	Sample window time during which final V_{BE} measurement is made.

3.4 Interface and physical dimensions. The interface and physical dimensions shall be as specified in [MIL-PRF-19500](#), and on [figure 1](#) herein.

3.4.1 Lead finish. The lead finish shall be solderable in accordance with [MIL-PRF-19500](#), [MIL-STD-750](#), and herein. Where a choice of lead finish is desired, it shall be specified in the acquisition document (see [6.2](#)).

3.4.2 Polarity. The polarity of the device types shall be as shown on [figure 1](#).

3.5 Electrical performance characteristics. Unless otherwise specified herein, the electrical performance characteristics are as specified in [1.3](#), [1.4](#), and [table I](#).

3.6 Electrical test requirements. The electrical test requirements shall be as specified in [table I](#).

3.7 Marking. Marking shall be in accordance with [MIL-PRF-19500](#).

3.8 Workmanship. Semiconductor devices shall be processed in such a manner as to be uniform in quality and shall be free from other defects that will affect life, serviceability, or appearance.

4. VERIFICATION

4.1 Classification of inspections. The inspection requirements specified herein are classified as follows:

- a. Qualification inspection (see 4.2).
- b. Screening (see [4.3](#)).
- c. Conformance inspection (see [4.4](#) and [tables I and II](#)).

4.2 Qualification inspection. Qualification inspection shall be in accordance with [MIL-PRF-19500](#) and as specified herein.

4.2.1 Group E qualification. Group E inspection shall be performed for qualification or re-qualification only. In case qualification was awarded to a prior revision of the specification sheet that did not request the performance of [table II](#) tests, the tests specified in [table II](#) herein that were not performed in the prior revision shall be performed on the first inspection lot of this revision to maintain qualification.

4.3 Screening (JANTX and JANTXV levels only). Screening shall be in accordance with table E-IV of MIL-PRF-19500, and as specified herein. The following measurements shall be made in accordance with table I herein. Devices that exceed the limits of table I herein shall not be acceptable.

Screen (see table E-IV of MIL-PRF-19500)	Measurement
	JANTX and JANTXV levels
3c (1)	Thermal impedance, see 4.3.1
9	I_{CEX1} and h_{FE2}
11	I_{CEX1} and h_{FE2} $\Delta I_{CEX1} = \pm 100$ percent of initial value or 100 nA dc, whichever is greater. $\Delta h_{FE2} = \pm 40$ percent of initial value.
12	See 4.3.2
13	See table I, subgroup 2 herein. $\Delta I_{CEX1} = 100$ percent of initial value or 100 nA dc, whichever is greater. $\Delta h_{FE2} = \pm 40$ percent of initial value.

(1) Thermal impedance shall be performed anytime after temperature cycling (screen 3a) and does not need to be repeated in screening requirements.

4.3.1 Thermal impedance. The thermal impedance measurements shall be performed in accordance with test method 3131 of MIL-STD-750 using the guidelines in that method for determining I_H , I_M , t_H , t_{sw} (and V_H where appropriate). The thermal impedance limit used in screen 3c and table I, subgroup 2 herein shall be set statistically by the supplier. Measurement delay time (t_{MD}) = 70 μ s maximum. See table II, subgroup 4 (group E) herein.

4.3.2 Power burn-in conditions. Power burn-in conditions shall be as follows: $T_J = +162.5^\circ\text{C} \pm 12.5^\circ\text{C}$, $V_{CE} \geq 10$ V dc. NOTE: No heat sink or forced air cooling on the devices shall be permitted.

4.4 Conformance inspection. Conformance inspection shall be in accordance with MIL-PRF-19500.

4.4.1 Group A inspection. Group A inspection shall be conducted in accordance with table E-V of MIL-PRF-19500 and table I herein. Electrical measurements (end-points) shall be in accordance with table I subgroup 2 herein.

* 4.4.2 Group B inspection. Group B inspection shall be conducted in accordance with the tests and conditions specified for subgroup testing in table E-VIB (JAN, JANTX, and JANTXV) of MIL-PRF-19500 and as follows.

<u>Subgroup</u>	<u>Method</u>	<u>Conditions</u>
B3	1037	$V_{CE} \geq 10$ V dc, adjust device current, or power, to achieve a minimum ΔT_J of $+100^\circ\text{C}$.

- * 4.4.3 Group C inspection. Group C inspection shall be conducted in accordance with the tests and conditions specified for subgroup testing in table E-VII of [MIL-PRF-19500](#) and as follows.

<u>Subgroup</u>	<u>Method</u>	<u>Conditions</u>
C2	2036	Test condition A; weight = 10 pounds (4.54 Kg); time = 15 s.
C5	3131	See 4.3.1 , $R_{\theta JC} = 2.66^{\circ}\text{C/W}$.
C6	1037	$V_{CE} \geq 10$ V dc, adjust device current, or power, to achieve a minimum ΔT_J of $+100^{\circ}\text{C}$.

4.4.4 Group E inspection. Group E inspection shall be conducted in accordance with the tests and conditions specified for subgroup testing in table E-IX of [MIL-PRF-19500](#) and as specified in [table II](#) herein. Electrical measurements (end-points) shall be in accordance with [table I](#), subgroup 2 herein.

4.5 Method of inspection. Methods of inspection shall be as specified in the appropriate tables and as follows.

4.5.1 Pulse response measurements. The conditions for pulse response measurement shall be as specified in section 4 of [MIL-STD-750](#).

* TABLE I. Group A inspection.

Inspection <u>1/</u>	MIL-STD-750		Symbol	Limit		Unit
	Method	Conditions		Min	Max	
<u>Subgroup 1</u> Visual and mechanical examination	2071					
<u>Subgroup 2</u> Thermal impedance <u>2/</u>	3131	See 4.3.1	$Z_{\theta JX}$			°C/W
Breakdown voltage, collector to emitter 2N6300 2N6301	3011	Bias condition D, $I_C = 100$ mA dc; pulsed (see 4.5.1)	$V_{(BR)CEO}$	60 80		V dc V dc
Collector to emitter cutoff current 2N6300 2N6301	3041	Bias condition A, $V_{BE} = -1.5$ V dc $V_{CE} = 60$ V dc $V_{CE} = 80$ V dc	I_{CEX1}		10 10	μ A dc μ A dc
Collector to emitter cutoff current 2N6300 2N6301	3041	Bias condition D $V_{CE} = 30$ V dc $V_{CE} = 40$ V dc	I_{CEO}		0.5 0.5	mA dc mA dc
Emitter to base cutoff current	3061	Bias condition D, $V_{EB} = 5$ V dc	I_{EBO}		2.0	mA dc
Forward-current transfer ratio	3076	$V_{CE} = 3$ V dc; $I_C = 1$ A dc; pulsed (see 4.5.1)	h_{FE1}	500		
Forward-current transfer ratio	3076	$V_{CE} = 3$ V dc; $I_C = 4$ A dc; pulsed (see 4.5.1)	h_{FE2}	750	18000	
Forward-current transfer ratio	3076	$V_{CE} = 3$ V dc; $I_C = 8$ A dc; pulsed (see 4.5.1)	h_{FE3}	100		
* Base emitter voltage (nonsaturated)	3066	Test condition B; $V_{CE} = 3$ V dc; $I_C = 4$ A dc; pulsed (see 4.5.1)	$V_{BE(ON)}$		2.8	V dc
Base emitter voltage (saturated)	3066	Test condition A; $I_C = 8$ A dc; $I_B = 80$ mA dc; pulsed (see 4.5.1)	$V_{BE(SAT)2}$		4.0	V dc
Saturation voltage; collector to emitter	3071	$I_C = 4$ A dc; $I_B = 16$ mA dc; pulsed (see 4.5.1)	$V_{CE(SAT)1}$		2.0	V dc
Saturation voltage; collector to emitter	3071	$I_C = 8$ A dc; $I_B = 80$ mA dc; pulsed (see 4.5.1)	$V_{CE(SAT)2}$		3.0	V dc

See footnotes at end of table.

* TABLE I. Group A inspection - Continued.

Inspection <u>1/</u>	MIL-STD-750		Symbol	Limit		Unit
	Method	Conditions		Min	Max	
<u>Subgroup 3</u>						
High-temperature operation:		$T_A = +150^\circ\text{C}$				
Collector to emitter cutoff current	3041	Bias condition A; $V_{BE} = -1.5\text{ V dc}$	I_{CEX2}			
2N6300		$V_{CE} = 60\text{ V dc}$			1.0	mA dc
2N6301		$V_{CE} = 80\text{ V dc}$			1.0	mA dc
Low-temperature operation:		$T_A = -55^\circ\text{C}$				
Forward-current transfer ratio	3076	$V_{CE} = 3\text{ V dc}$; $I_C = 4\text{ A dc}$; pulsed (see 4.5.1)	h_{FE4}	200		
<u>Subgroup 4</u>						
Small-signal, short-circuit forward-current transfer ratio	3206	$V_{CE} = 3\text{ V dc}$; $I_C = 3\text{ A dc}$; $f = 1\text{ kHz}$	h_{fe}	300		
Magnitude of small-signal, short-circuit forward-current transfer ratio	3306	$V_{CE} = 3\text{ V dc}$; $I_C = 3\text{ A dc}$; $f = 1.0\text{ MHz}$	$ h_{fe} $	25	350	
Pulse response transfer ratio	3251	Test condition A, except test circuit and pulse requirements in accordance with figures 4 and 5 herein				
Turn-on time		$V_{CC} = 30\text{ V dc}$, (see figure 4), $I_C = 4\text{ A dc}$, $I_{B1} = 16\text{ mA dc}$	t_{on}		2.0	μs
Turn-off time		$V_{CC} = 30\text{ V dc}$, (see figure 5), $I_C = 4\text{ A dc}$, $I_{B1} = -I_{B2} = 16\text{ mA dc}$	t_{off}		8.0	μs
Open-circuit output capacitance	3236	$V_{CB} = 10\text{ V dc}$; $I_E = 0$, $100\text{ kHz} \leq f \leq 1\text{ MHz}$	C_{obo}		200	pF
<u>Subgroup 5</u>						
Safe operating area (continuous dc)	3051	$T_C = +25^\circ\text{C}$ to $+10^\circ\text{C}$, $t = 1\text{ s}$, 1 cycle (see figure 6)				
<u>Test 1</u>						
All device types		$V_{CE} = 8.0\text{ V dc}$; $I_C = 8\text{ A dc}$				

See footnotes at end of table.

* TABLE I. Group A inspection - Continued.

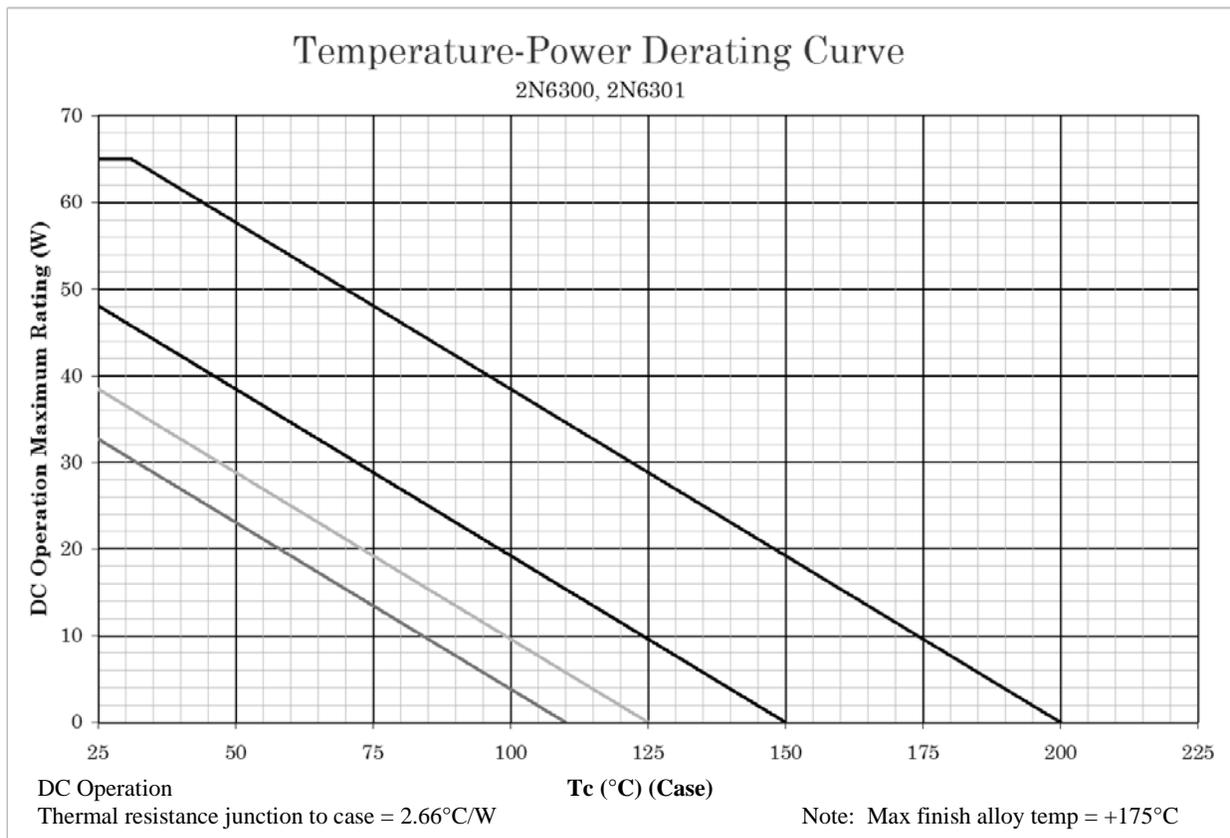
Inspection <u>1/</u>	MIL-STD-750		Symbol	Limit		Unit
	Method	Conditions		Min	Max	
<u>Subgroup 5</u> - Continued						
<u>Test 2</u> All device types		$V_{CE} = 20 \text{ V dc}; I_C = 2.0 \text{ A dc}$				
<u>Test 3</u> 2N6300 2N6301		$V_{CE} = 60 \text{ V dc}; I_C = 100 \text{ mA dc}$ $V_{CE} = 80 \text{ V dc}; I_C = 100 \text{ mA dc}$				
Safe operating area (switching)	3053	Load condition B, (clamped inductive load), $T_A = +25^\circ\text{C}$, $t_r + t_f \leq 1.0 \mu\text{s}$ duty cycle $\leq 10\%$, $t_p = 1 \text{ ms}$ (vary to obtain I_C), $R_s = 0.1 \text{ ohms}$, $R_{BB1} = 80 \text{ ohms}$, $V_{BB1} = 16 \text{ V dc}$, $R_{BB2} = 100 \text{ ohms}$, $V_{BB2} = 1.5 \text{ V dc}$, $V_{CC} = 50 \text{ V dc}$, $I_C = 8 \text{ A dc}$, $R_L \leq 2 \text{ ohms}$, $L = 1 \text{ mH}$				
2N6300 2N6301		Clamp voltage = 60 V dc Clamp voltage = 80 V dc				
Safe operating area (switching)	3053	Load condition C, (unclamped inductive load) (see figure 7), $T_A = +25^\circ\text{C}$, duty cycle $\leq 10\%$, $R_s \leq 0.1 \text{ ohms}$				
<u>Test 1</u>		$t_p = 1 \text{ ms}$ (vary to obtain I_C), $R_{BB1} = 80 \text{ ohms}$, $V_{BB1} \geq 12 \text{ V dc}$, $R_{BB2} = \infty$, $V_{CC} \geq 30 \text{ V dc}$, $I_C = 8 \text{ A dc}$, $R_L \leq 0.5 \text{ ohms}$, $L = 1 \text{ mH}$ at 8 A dc				
<u>Test 2</u>		$t_p = 1 \text{ ms}$ (vary to obtain I_C), $R_{BB1} = 80 \text{ ohms}$, $V_{BB1} \geq 12 \text{ V dc}$, $R_{BB2} = \infty$, $V_{BB2} = 0 \text{ V dc}$, $V_{CC} \geq 30 \text{ V dc}$, $I_C = 0.2 \text{ A dc}$, $R_L \leq 0.5 \text{ ohms}$, $L = 100 \text{ mH}$ at 0.2 A dc				
Electrical measurements		See subgroup 2 of this table				
<u>Subgroups 6 and 7</u>						
Not applicable						

1/ For sampling plan, see [MIL-PRF-19500](#).

2/ This test required for the following end-point measurements only:
Group B, subgroups 2 and 3 (JAN, JANTX, and JANTXV).
Group C, subgroups 2 and 6.
Group E, subgroups 1 and 2.

TABLE II. Group E inspection (all quality levels) - for qualification and re-qualification only.

Inspection	MIL-STD-750		Qualification sample plan
	Method	Conditions	
<u>Subgroup 1</u>			45 devices; c = 0
Temperature cycling (air to air)	1051	500 cycles.	
Hermetic seal	1071		
Fine leak			
Gross leak			
Electrical measurements		See table I , subgroup 2 herein.	
<u>Subgroup 2</u>			45 devices; c = 0
Blocking life	1048	Test temperature = +125°C; V _{CB} = 80 percent rated; T = 1,000 hours.	
Electrical measurements		See table I , subgroup 2 herein.	
<u>Subgroup 4</u>			Sample size N/A
Thermal impedance curves		See MIL-PRF-19500 .	
<u>Subgroup 5</u>			3 devices; c = 0
Barometric pressure (reduced)	1001	Test condition C. See 1.3 .	
<u>Subgroup 6</u>			11 devices
Electrostatic discharge sensitivity classification	1020		
<u>Subgroup 8</u>			45 devices; c = 0
Reverse voltage leakage stability	1033	Condition B for all device types.	

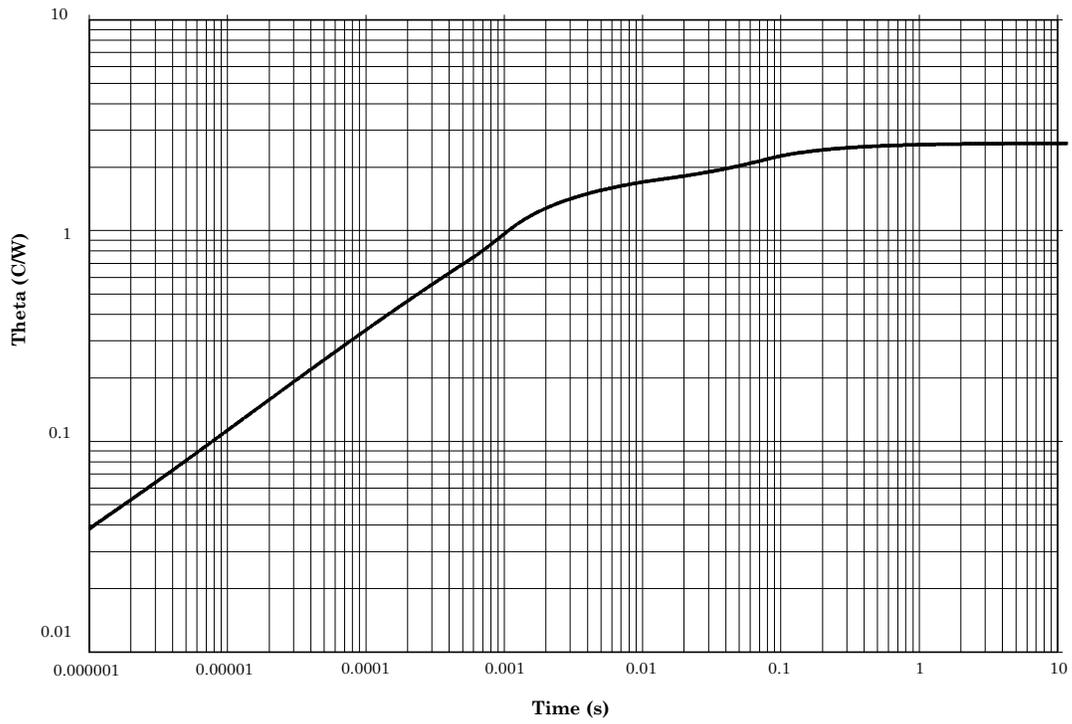


NOTES:

1. All devices are capable of operating at $\leq T_J$ specified on this curve. Any parallel line to this curve will intersect the appropriate power for the desired maximum T_J allowed.
2. Derate design curve constrained by the maximum junction temperature ($T_J \leq +200^\circ\text{C}$) and power rating specified (see 1.3 herein.)
3. Derate design curve chosen at $T_J \leq +150^\circ\text{C}$ where the maximum temperature of electrical test is performed.
4. Derate design curves chosen at $T_J \leq +125^\circ\text{C}$ and $+110^\circ\text{C}$ to show power rating where most users want to limit T_J in their application.

FIGURE 2. Temperature-power derating graph for device types 2N6300 and 2N6301.

Maximum Thermal Impedance



$R_{\theta JC} = 2.66 \text{ } ^\circ\text{C/W}$

FIGURE 3. Thermal impedance graph.

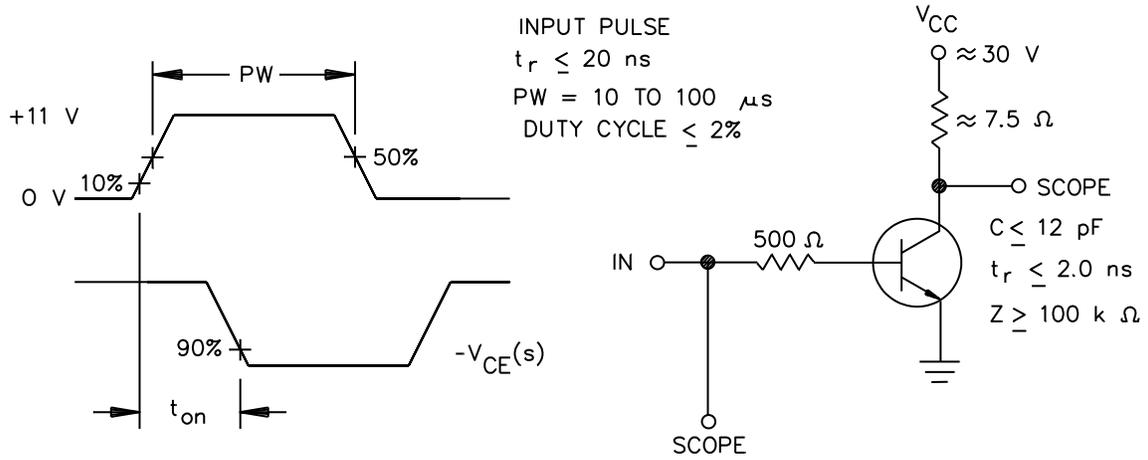
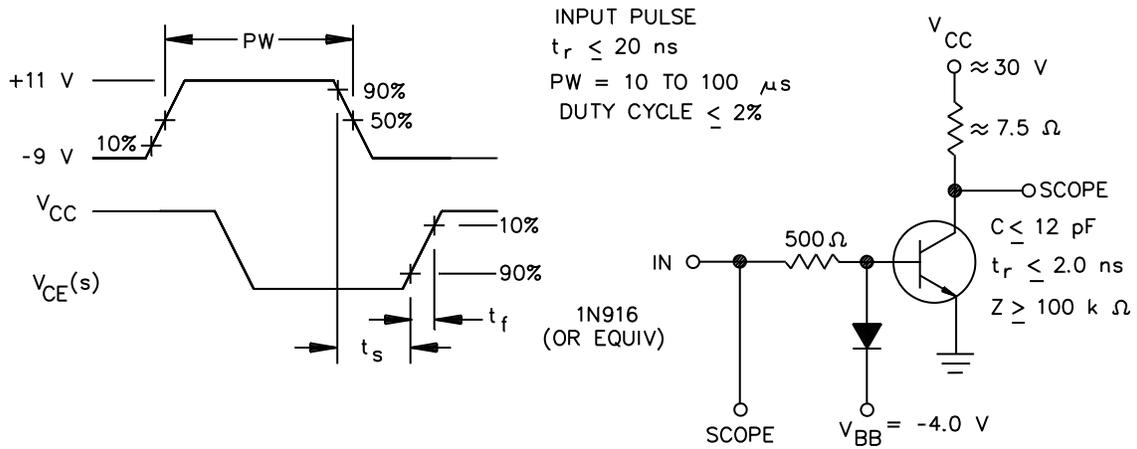


FIGURE 4. Turn on (t_{on}) time test circuit.



NOTE: $t_s + t_f = t_{off}$

FIGURE 5. Turn off (t_{off}) time test circuit.

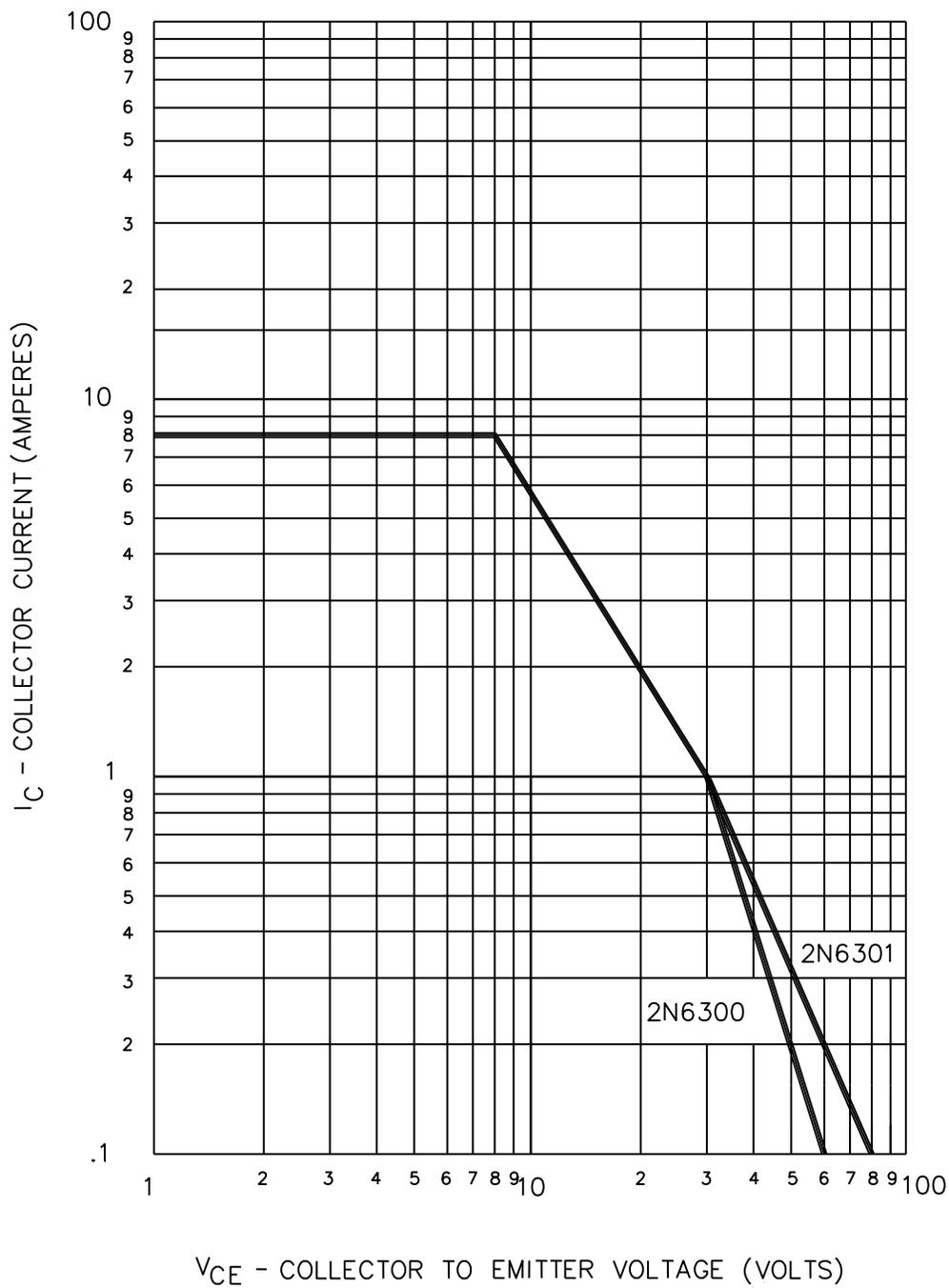


FIGURE 6. Maximum safe operating graph (dc).

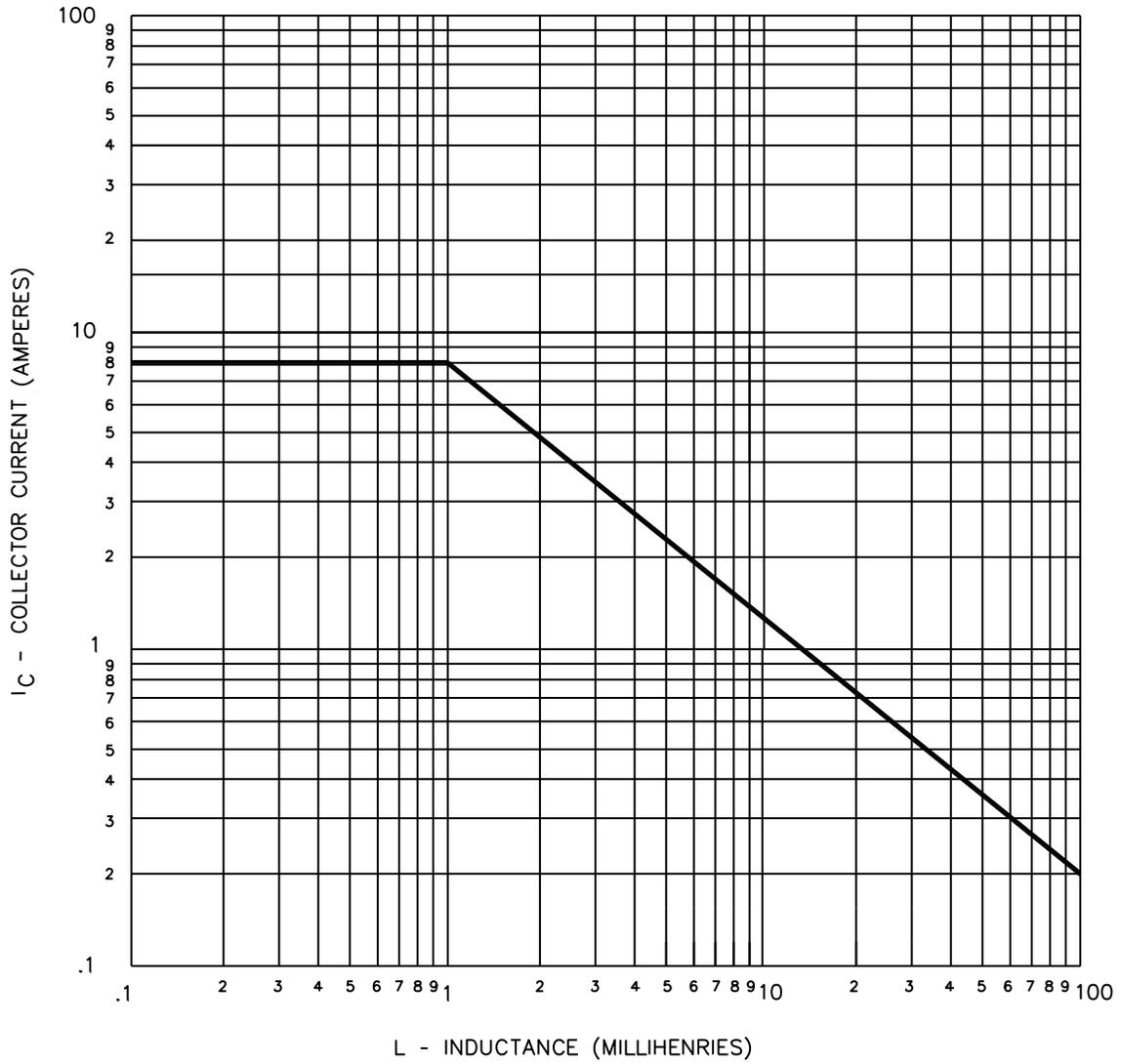


FIGURE 7. Safe operating area for switching between saturation and cutoff (unclamped inductive load).

5. PACKAGING

5.1 Packaging. For acquisition purposes, the packaging requirements shall be as specified in the contract or order (see 6.2). When packaging of materiel is to be performed by DoD or in-house contractor personnel, these personnel need to contact the responsible packaging activity to ascertain packaging requirements. Packaging requirements are maintained by the Inventory Control Point's packaging activities within the Military Service or Defense Agency, or within the Military Service's system commands. Packaging data retrieval is available from the managing Military Department's or Defense Agency's automated packaging files, CD-ROM products, or by contacting the responsible packaging activity.

6. NOTES

(This section contains information of a general or explanatory nature that may be helpful, but is not mandatory. The notes specified in [MIL-PRF-19500](#) are applicable to this specification.)

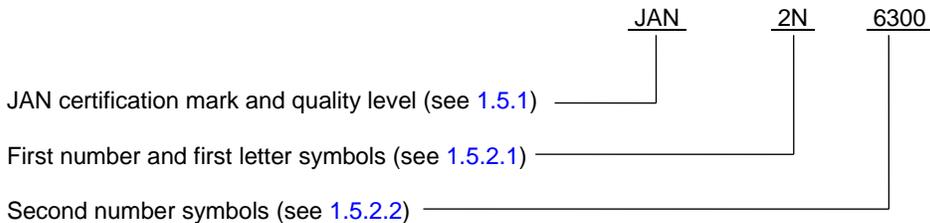
6.1 Intended use. Semiconductors conforming to this specification are intended for original equipment design applications and logistic support of existing equipment.

6.2 Acquisition requirements. Acquisition documents should specify the following:

- a. Title, number, and date of this specification.
- b. Packaging requirements (see 5.1).
- c. Lead finish (see 3.4.1).
- * d. The complete Part or Identifying Number (PIN), see 1.5.

* 6.3 Qualification. With respect to products requiring qualification, awards will be made only for products which are, at the time of award of contract, qualified for inclusion in Qualified Manufacturers List ([QML 19500](#)) whether or not such products have actually been so listed by that date. The attention of the contractors is called to these requirements, and manufacturers are urged to arrange to have the products that they propose to offer to the Federal Government tested for qualification in order that they may be eligible to be awarded contracts or orders for the products covered by this specification. Information pertaining to qualification of products may be obtained from DLA Land and Maritime, ATTN: VQE, P.O. Box 3990, Columbus, OH 43218-3990 or e-mail vqe.chief@dla.mil. An online listing of products qualified to this specification may be found in the Qualified Products Database (QPD) at <https://assist.dla.mil>.

* 6.4 PIN construction example. The PINs for encapsulated devices are construction using the following form.



* 6.5 List of PINs.

* 6.5.1 List of PINs. The following is a list of possible PINs available on this specification sheet.

PINs for devices of the base quality level	PINs for devices of the "TX" quality level	PINs for devices of the "TXV" quality level
JAN2N6300	JANTX2N6300	JANTXV2N6300
JAN2N6301	JANTX2N6301	JANTXV2N6301

* 6.6 Changes from previous issue. The margins of this specification are marked with asterisks to indicate where changes from the previous issue were made. This was done as a convenience only and the Government assumes no liability whatsoever for any inaccuracies in these notations. Bidders and contractors are cautioned to evaluate the requirements of this document based on the entire content irrespective of the marginal notations and relationship to the last previous issue.

Custodians:
 Army - CR
 Navy - EC
 Air Force - 85
 NASA - NA
 DLA - CC

Preparing activity:
 DLA - CC
 (Project 5961-2014-093)

Review activities:
 Army - AR, AV, MI
 Air Force - 19, 99

NOTE: The activities listed above were interested in this document as of the date of this document. Since organizations and responsibilities can change, you should verify the currency of the information above using the ASSIST Online database at <https://assist.dla.mil>.